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INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449	Docket No. 52433/859	Application No. 10/588,837	
	Applicant(s) Hitoshi ASahi et al.	Examiner VELASQUEZ, VANESSA T	
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U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/NTV/	9-3545	01/07/1997	JP			Abstract	
↓	9-49025	02/18/1997	JP			Abstract	
↓	2004-35925	02/05/2004	JP			Abstract	
↓	2002-212680	07/31/2002	JP			Abstract	
↓	2002-266055	09/18/2002	JP			Abstract	
↓	2002-129283	05/09/2002	JP			Abstract	
/NTV/	2002-349177	12/04/2002	JP			Abstract	

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.

EXAMINER	/Vanessa T Velasquez/	DATE CONSIDERED	12/17/2010
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			